

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

HSML, P.C.

Applicant:

NIISOE

Examiner:

NIISOE

Serial No.:

10/750,359

Group Art Unit:

2891

Filed:

December 29, 2003

Docket No.:

10873.1388US01

Title:

METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S Patent and Trademark Office on October 5,

2005.

Name: Peggy J. Ricrimove

CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

Please change the correspondence address for the above-referenced patent application to:

> Hamre, Schumann, Mueller & Larson, P.C. P.O. Box 2902-0902 Minneapolis, MN 55402

If there are any questions regarding this matter, please call the undersigned at 612.455.3800.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER & LARSON, P.C. P.O. Box 2902-0902 Minneapolis, MN 55402-0903

(612) 485-380b

Dated: October 5, 2005

By:

ouglas P. Mueller

eg. No. 30,300

DPM/pjk

52835 PATENT TRADEMARK OFFICE